

euspen International Conference, Delft, June 2010 – Timetable

MON 31 ST MAY	TUES 1 ST JUNE	WEDS 2 ND JUNE	THURS 3 RD JUNE	FRI 4 TH JUNE
<p>9.00-17.00 Tutorials</p>	<p>08.30 Conference Registration Open</p> <p style="text-align: center;">Opening Session <i>Plenary</i></p> <p>09.15 Presidential Address Dr Henny Spaan euspen President</p> <p>09.30 Keynote 1: 'Extreme Ultra Violet Lithography' Dr J. Benschop, ASML, NL -</p> <p>10.00-11.00 Oral Session I EMERGING PATTERNING TECHNOLOGIES AND METHODS Chairmen: Prof. J. Van Eijk, University of Delft, NL Dr J. Benschop, ASML, NL</p>	<p>09.00 Keynote 2: 'Adaptive Optics - Current International Status' Prof. R. Munnig Schmitt University of Delft, NL <i>Plenary</i> Chairman: Keith Carlise, Lawrence Livermore National Laboratory, US</p> <p>09.35-11.00 Oral Session 4 HIGH PRECISION MECHATRONICS <i>Plenary</i> Chairmen: Prof. D. Reynaerts, KU Leuven, BE Mr D. Arneson, Professional Instruments, US</p>	<p>9.00-10.00 Oral Session 7 PRECISION ENGINEERING & NANOTECHNOLOGY- STATE OF THE ART JAPAN <i>Plenary</i> Chairman: Prof. T. Moriwaki, Kobe University, JP</p> <p>10.00 POSTER SESSIONS 5,6,9,10</p>	<p>Technical Tours to: TNO/VSL Estec</p>
	<p>11.00-11.30 Coffee</p>	<p>11.00-11.30 Coffee</p>	<p>10.30-11.00 Coffee</p>	
	<p>11.30-13.15 Oral Session 2A NANO & MICRO METROLOGY <i>Plenary</i> Chairman: Dr H. Bosse, PTB, DE Dr H. Haitjema, Mitutoyo Research Centre, NL</p>	<p>11.30-13.15 Oral Session 5A ULTRA PRECISION MANUFACTURING & ASSEMBLY PROCESSES I <i>Plenary</i> Chairmen: Dr K. Beckstette, Carl Zeiss AG, Mr. M. Tricard QED Technologies, US</p> <p>[13.15-13.30 euspen Annual General Meeting <i>Plenary</i>]</p>	<p>11.00-11.30 POSTER SESSIONS 5,6,9,10</p> <p>11.10-11.30 Exhibitors Meeting <i>Plenary</i></p> <p>11.30-12.30 Oral Session 8 PRECISION ENGINEERING & NANOTECHNOLOGY- STATE OF THE ART US <i>Plenary</i> Chairmen: Dr. P. Subrahmanyam, Rapt Industries, US & ASPE Dr. W. Tyler Estler, NIST, US</p>	
	<p>13.15-14.00 Lunch</p>	<p>13.15-14.00 Lunch</p>	<p>12.30-13.15 Lunch</p>	

	14.00- 14.30 Coffee	14.00-14.30 Coffee	13.15-13.45 Coffee	
14.30-17.30 Conference Registration Aula CongressCentre	14.30-16.15 COMMERCIAL SESSION <i>Plenary</i> Chairman: Mr Ton Peijnenburg, VDL Enabling Technologies Group, NL	14.30-16.15 POSTER SESSIONS 1-4	13.45 – 15.30 Oral Session 9 IMPORTANT/NOVEL ADVANCES IN PRECISION ENGINEERING & NANO TECHNOLOGIES <i>Plenary</i> Chairmen: Prof. H. Van Brussel, KU Leuven, BE Prof. L. De Chiffre, Denmark Technical University, DK	
	16.15-16.45 Coffee	16.15-16.45 Coffee	15.30-16.00 Coffee	
	16.45-18.30 Oral Session 3 ULTRA PRECISION MACHINES & CONTROL <i>Plenary</i> Chairmen: Prof. P. Shore, UPS2, UK Mr R. Nefkens, Hembrug, NL	16.45-17.50 Oral Session 2B NANO & MICRO METROLOGY <i>Plenary</i> Chairmen: Dr Kim Carneiro, DFM, DK Dr Onno Hoitinga, Philips , NL	16.00-16.10 Poster and Heidenhain Scholar Awards 16.10-17.10 Oral Session 5B ULTRA PRECISION MANUFACTURING & ASSEMBLY PROCESSES II <i>Plenary</i> Chairmen: Prof. S. Zelenika, Univ. of Rijek, CR Dr W. Knapp, ETH, CH 17.10 Closing remarks Prof. Paul Shore	
18.30 Welcome Reception, Botanical Gardens, Delft	18.30-19.30 euspen Football Challenge Match FREE EVENING	17.50 - 18.00 Co-Nanomet Activities Dr T. Burke, euspen Ltd 18.00 -18.10 euspen 11 th International Conference 18.10 - 18.25 euspen Review Prof P. McKeown 19.30 Networking Dinner, Madurodam	FREE EVENING	